Docket No.: 057810-0095 PATEN

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yasuhiro TAKEDA, et al.

Application No.: 10/811,811

Filed: March 30, 2004

Customer Number: 20277

Confirmation Number: 2835

Group Art Unit: 2815

Examiner: M. Landau

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Mail Stop Amendment Transmittal Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	11	9	2	\$50.00 =	\$100.00
Independent Claims	35	30	5	\$200.00 =	\$1000.00
		Multiple dependent claims newly presented			\$0.00
Fee for extension of time				\$0.00	
					\$0.00
		Total of Above Calculations			\$1100.00

Please charge my Deposit Account No. <u>500417</u> in the amount of \$1100.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Arthur J. Steiner

Registration No. 26,106

Please recognize our Customer No. 20277 as our correspondence address.

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Date: May 23, 2006



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Filed: March 30, 2004 : Examiner: Landau, Matthew C.

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING SEMICONDUCTOR

DEVICE

## **AMENDMENT**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated March 1, 2006.

05/25/2006 HALI11 00000060 500417 10811811

01 FC:1202 100.00 DA 02 FC:1201 1000.00 DA